

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

10/500002

In re application of: Satoshi KAMIYAMA et al.

Serial Number: Not Yet Assigned

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Filed: June 23, 2004

For: **GROUP III-NITRIDE SEMICONDUCTOR SUBSTRATE AND PRODUCTION
METHOD**

Attorney Docket No.: 042398

Customer No.: 38834

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

June 23, 2004

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,
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Enclosures: PTO-1449; References (9) and international search report.

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INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 042398	Serial No. New Appln.
	Applicant(s): Satoshi KAMIYAMA et al.	
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FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
_____	AA	EP1 176 231	01/30/02	EPO	Yes. Cited in the int'l. search report.

OTHER DOCUMENTS

_____	AB	Patent Abstracts of Japan, Publication No.: 2003-104800, dated 04/09/03. Cited in the int'l. search report.
_____	AC	Patent Abstracts of Japan, Publication No.: 10-095699, dated 04/14/98. Cited in the specification.
_____	AD	Patent Abstracts of Japan, Publication No.: 11-162847, dated 06/18/99. Cited in the specification.
_____	AE	Patent Abstracts of Japan, Publication No.: 11-103135, dated 04/13/99. Cited in the specification.
_____	AF	Patent Abstracts of Japan, Publication No.: 11-251253, dated 09/17/99. Cited in the specification.
_____	AG	Patent Abstracts of Japan, Publication No.: 2001-060719, dated 03/06/01. Cited in the specification.
_____	AH	Patent Abstracts of Japan, Publication No.: 2001-308464, dated 11/02/01. Cited in the specification.
_____	AI	Hiroyuki KINOSHITA et al; Japan Journal of Applied Physics, Vol. 40, Part 2, No. 12A, pp. L1280-L1282. Dec. 1, 2001. Cited in the specification.
Examiner		
Date Considered		